

FIG. 1A

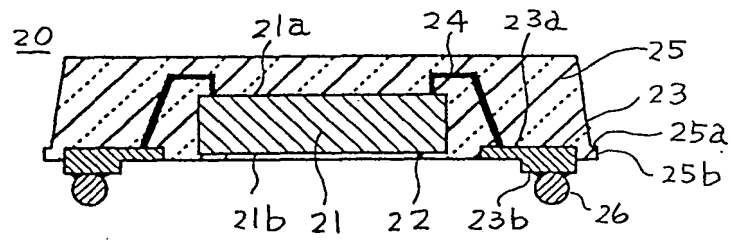
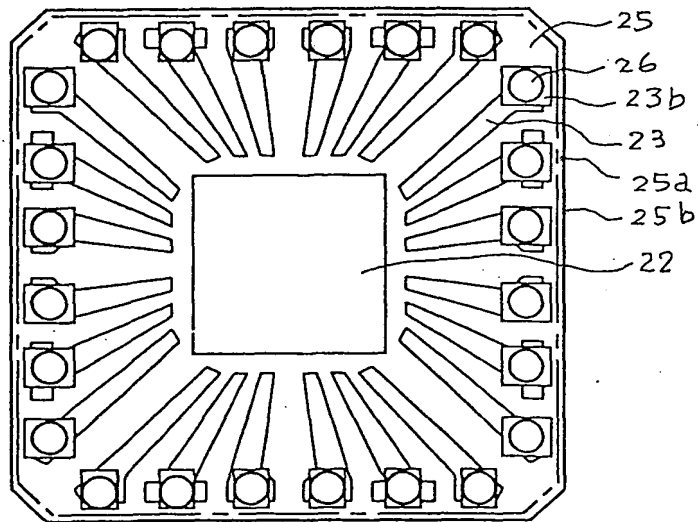


FIG. 1B



Title: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

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202-737-6770

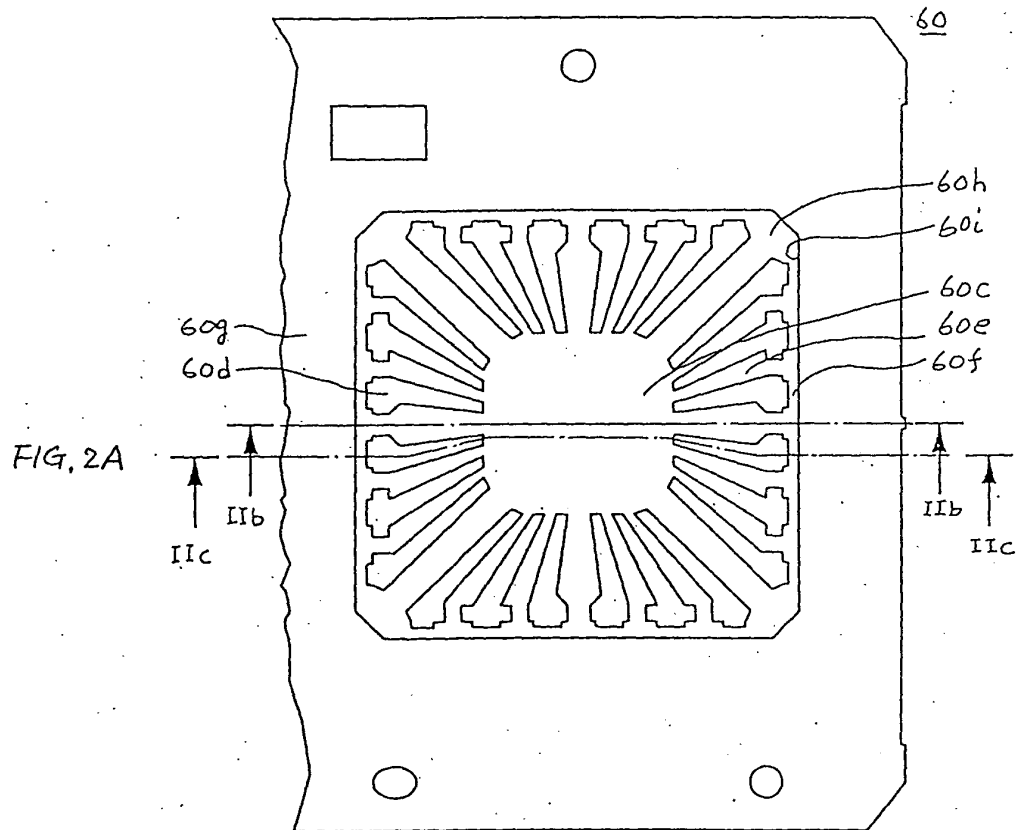


FIG. 2B

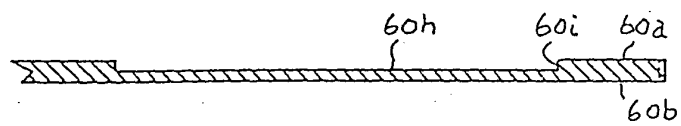


FIG. 2C

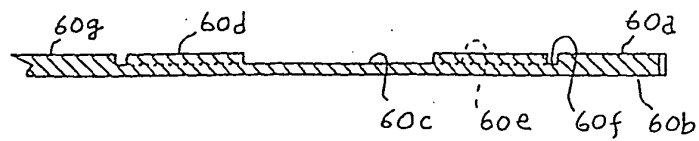


FIG. 3A

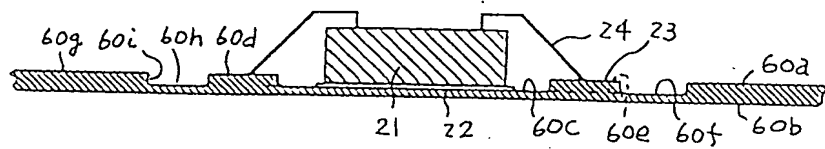


FIG. 3B

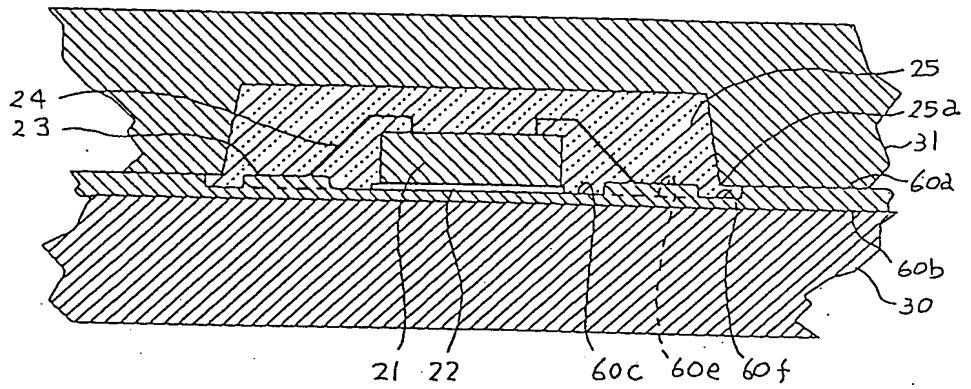


FIG. 3C

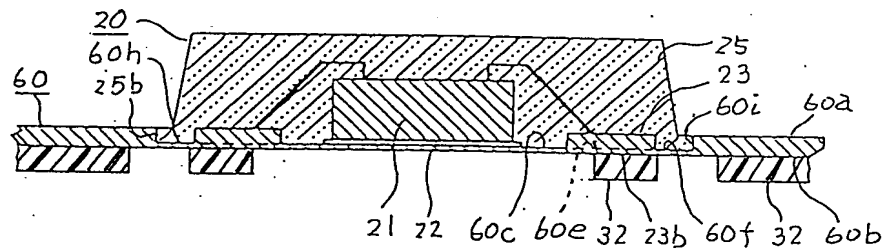


FIG. 3D

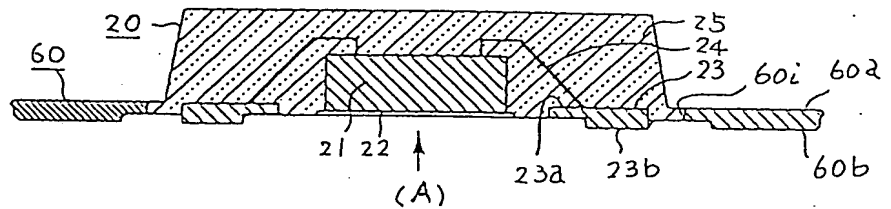
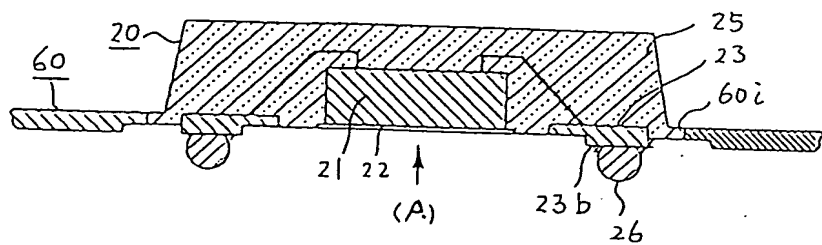
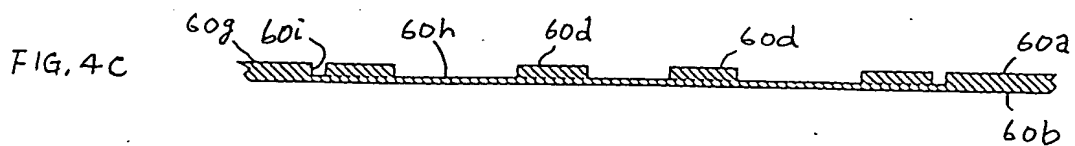
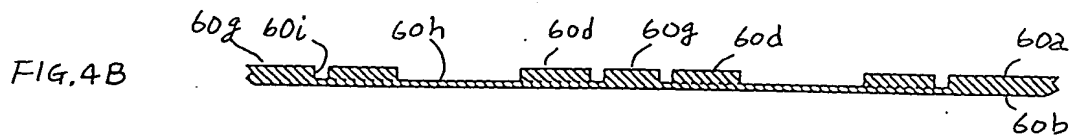
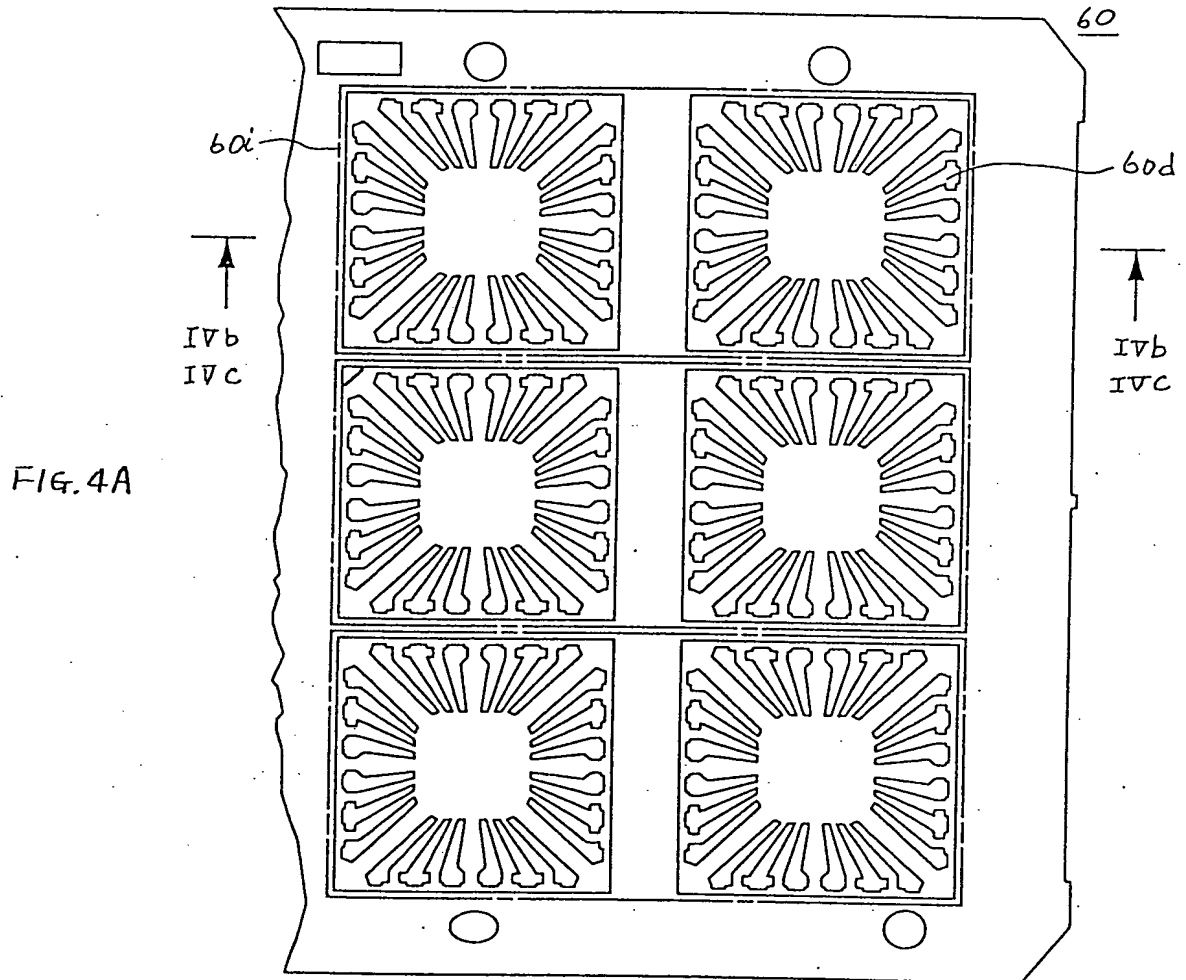
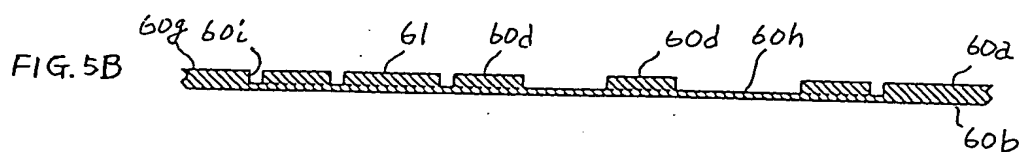
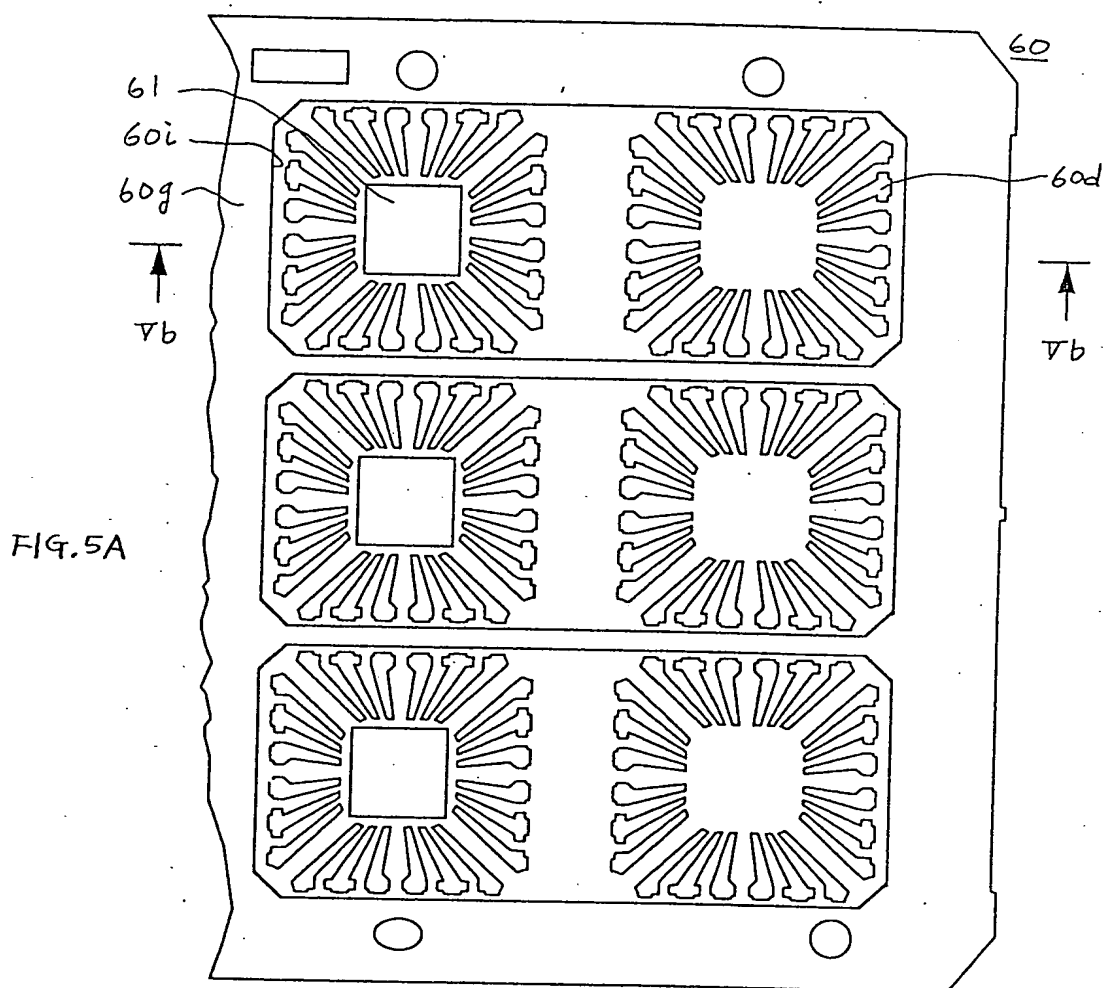
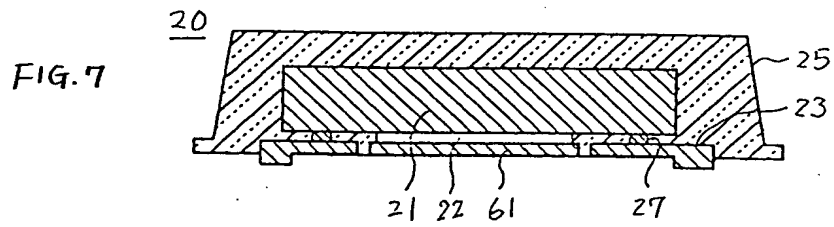
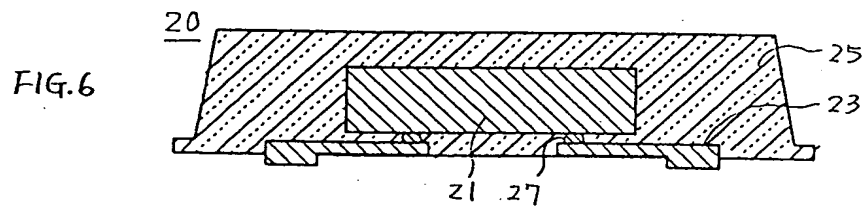


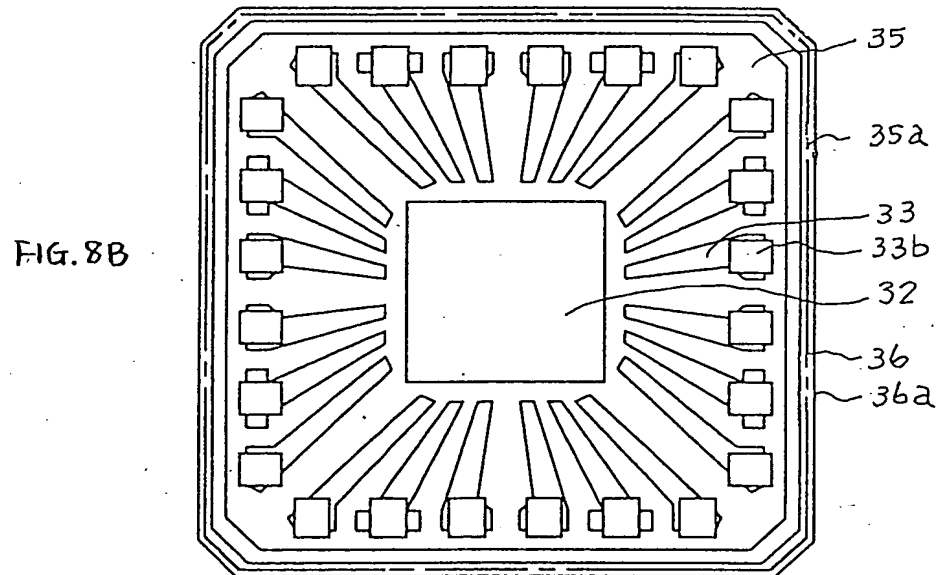
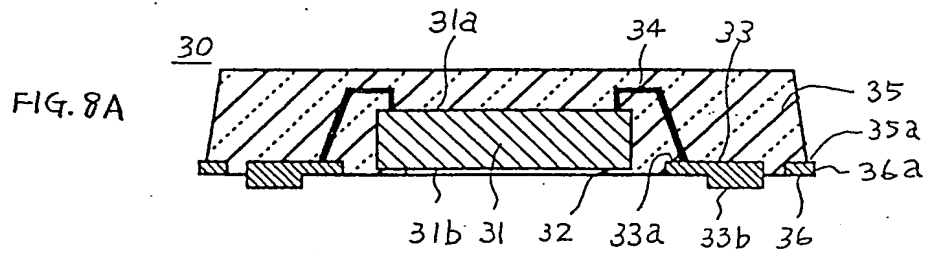
FIG. 3E

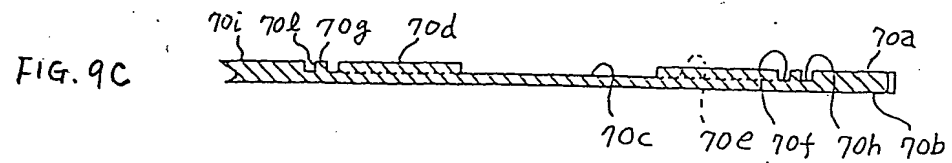
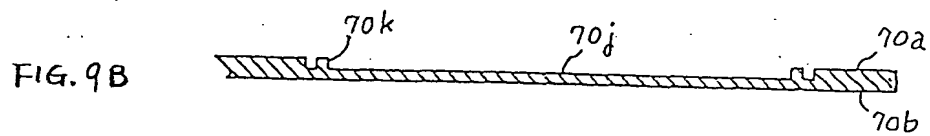
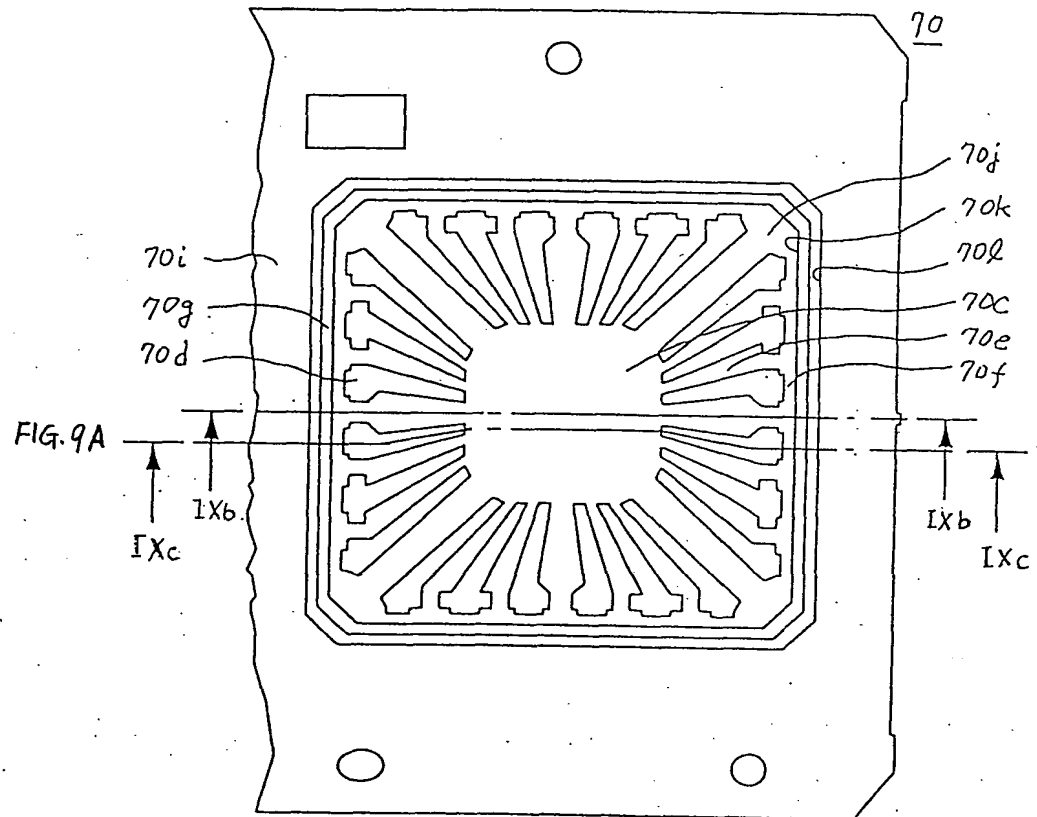














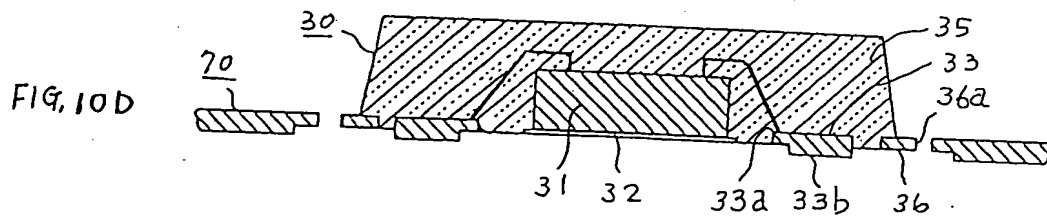
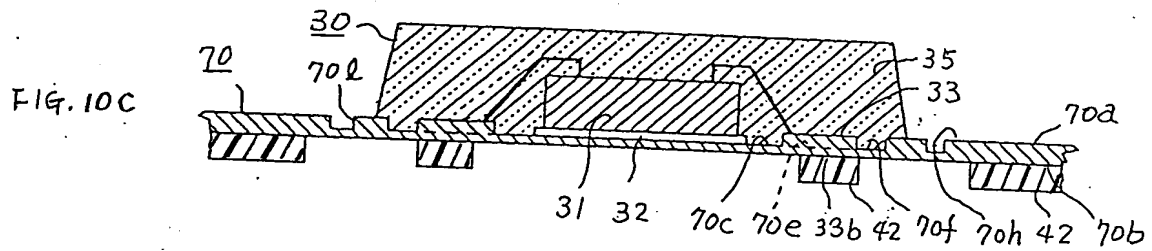
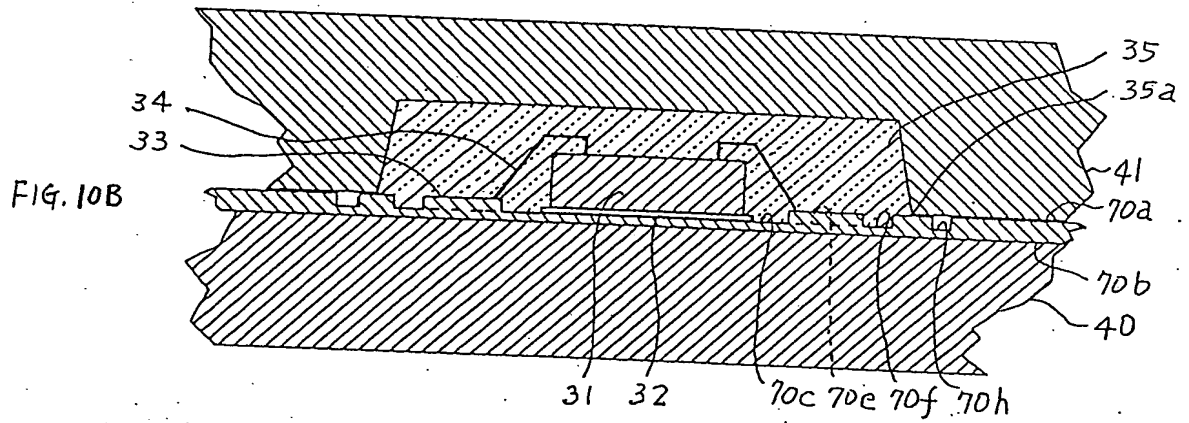
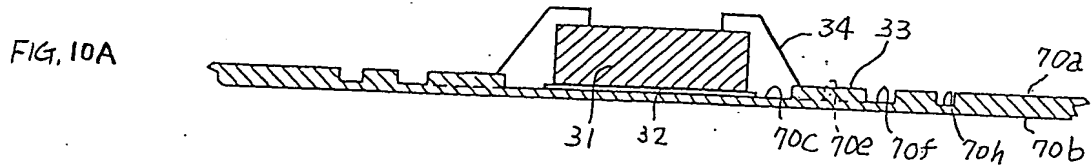


FIG. 11A

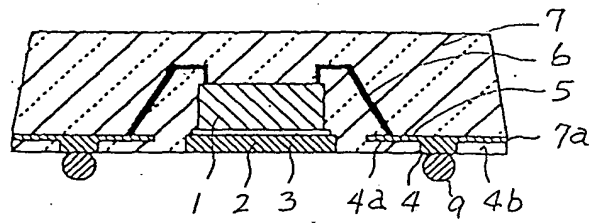


FIG. 11B

